

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**



APPLICANT(S): Hajime KAWANO et al.  
SERIAL NO. : 09/315,988  
FILED : 21 May 1999  
FOR : ELECTRON BEAM LITHOGRAPHY SYSTEM  
ART UNIT : 2881  
EXAMINER : K. Fernandez

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FOR PATENTS  
Washington, D.C. 20231

**INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. § 1.97 & § 1.98**

S I R:

In conformance with Applicants' duty of disclosure under 37 C.F.R. § 1.56 and § 1.97(c)(1), the references listed on the attached form PTO-1449 are hereby brought to the Examiner's attention.

In compliance with 37 C.F.R. § 1.98, copies of the references are submitted herewith.

**Statement of Relevancy**

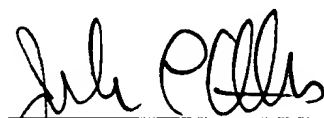
JP 06-333796 A was cited in an Office Action issued on 27 February 2002 by the Japanese Patent Office. (A copy of U.S. Patent No. 5,754,443, which corresponds to said Japanese reference, is enclosed for the Examiner's convenience).

**Certification Pursuant to 37 C.F.R. 1.97(e)(1)**

The undersigned attorney hereby certifies that the Japanese reference contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear in the "references cited" on any patent to issue therefrom.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'John C. Altmiller', written over a horizontal line.

John C. Altmiller  
(Reg. No. 25,951)

Date: 24 May 2002

KENYON & KENYON  
1500 K Street, N.W., Suite 700  
Washington, D.C. 20005

(202) 220-4200 Tel.  
(202) 220-4201 Fax

**FORM PTO-1449**  
**INFORMATION DISCLOSURE**  
**STATEMENT BY APPLICANT(S)**

Atty Docket No. : 29273/502  
 Serial No. : 09/315,988  
 Applicants : H. KAWANO et al.  
 Filed : 21 May 1999  
 Group Art Unit : 2881  
 Examiner : K. Fernandez



**U.S. PATENT DOCUMENTS**

Examiner Initial	Patent Number	Patent Date	Name	Class/ Subclass	Filing Date
	5,754,443	05/19/98	Y. MANABE	364,491	

**FOREIGN PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Country	Class/ Subclass	Translation Yes No
	06-333796	12/02/94	Japan		ABS.

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner  
Initial

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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